

NIT-215

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

S. KONDO et al

Serial No. 09/637,570

Group Art Unit: 2812

Filed: August 14, 2000

Examiner: Ha T. Nguyen

For: POLISHING METHOD, METALLIZATION FABRICATION  
METHOD, METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE AND SEMICONDUCTOR DEVICE

PETITION FOR EXTENSION OF TIME

FAX RECEIVED

Commissioner for Patents  
Washington, D.C. 20231

MAR 17 REC'D

TECHNOLOGY CENTER 2800

Sir:

It is respectfully requested that a one-month Extension of Time, to and including March 15, 2003, be granted in which to respond to the Office Action dated November 15, 2002 in the above-identified application.

The Commissioner is authorized to charge Deposit Account No. 50-1417 in the amount of \$110.00 for the Extension of Time fee.

The Commissioner is hereby authorized to charge any additional payment due, or to credit any overpayment, to Deposit Account No. 50-1417.

Respectfully submitted,



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Date: March 17, 2003

#14/687  
Amended  
3/20/03